



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

May 27, 2022
 IGI Report Number **LG530200684**
 Description **LABORATORY GROWN
DIAMOND**
 Shape and Cutting Style **EMERALD CUT**
 Measurements **6.49 X 4.64 X 3.21 MM**

GRADING RESULTS

Carat Weight **1.00 CARAT**
 Color Grade **G**
 Clarity Grade **VVS 2**

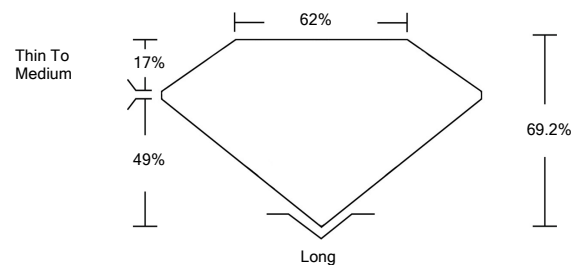
ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**
 Symmetry **EXCELLENT**
 Fluorescence **NONE**
 Inscription(s) **LABGROWN IGI LG530200684**

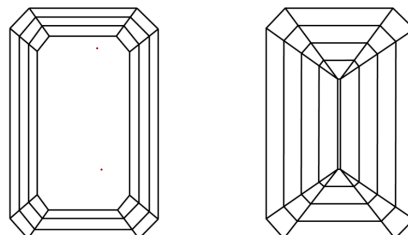
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process and may include post-growth treatment.
 Type IIa

LG530200684

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
 Green symbols indicate external characteristics.

GRADING SCALES

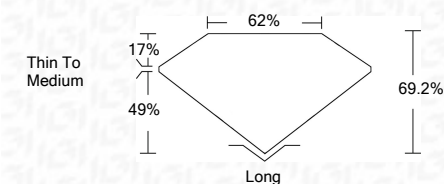
COLOR GRADING SCALE	CL	NC	FT	VLT	LT	
	COLORLESS D-F	NEAR COLORLESS G-J	FAINT K-M	VERY LIGHT N-R	LIGHT S-Z	
CLARITY (10x) GRADING SCALE	FL	IF	VVS	VS	SI	I
	FLAWLESS INTERNALLY FLAWLESS	VERY VERY SLIGHTLY INCLUDED	VERY SLIGHTLY INCLUDED	SLIGHTLY INCLUDED	INCLUDED	



LASERSCRIBESM

Sample Image Used

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IGI

May 27, 2022
 IGI Report No. LG530200684
EMERALD CUT
 6.49 X 4.64 X 3.21 MM
 Carat Weight 1.00 CARAT
 Color Grade G
 Clarity Grade VVS 2
 Depth 69.2%
 Table 62%
 Girdle Thin To Medium
 Culet Long
 Polish EXCELLENT
 Symmetry EXCELLENT
 Fluorescence NONE
 Inscription(s) LABGROWN IGI LG530200684
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 Type IIa